



Environmental Kelvin Probe Systems

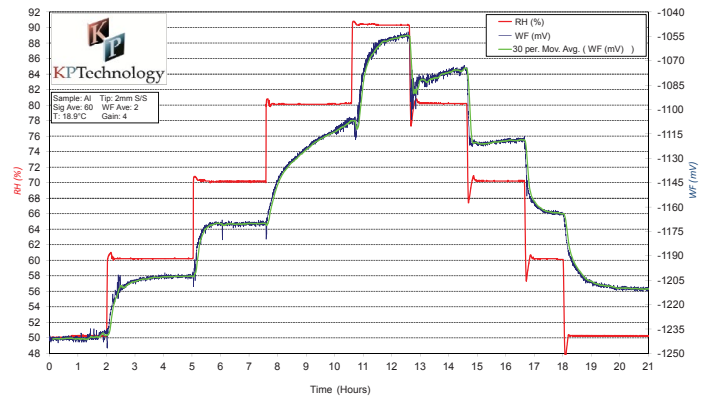
RHC010, RHC020, RHC030, RHC040

System Description

The Relative Humidity Kelvin Probe (RHC) systems are the ideal solution for monitoring samples in a controlled atmosphere for work function (Φ), otherwise known as Volta potential ($\Delta\psi$), determination. The RHC systems have the ability to automatically control the relative humidity within the chamber from 20% to 80% using the easily programmable software.

As well as RH control, the RHC020 and RHC040 Kelvin probe systems come with the KP Technology Ltd Scanning Kelvin Probe platform, perfect for plotting the effect of corrosion over the surface of a sample and providing more insight into corrosion protection and resistance.

The RHC030 and RHC040 come with the added benefit of nitrogen atmosphere control with the ability to go down to <1% oxygen within the system.



Effect of relative humidity on aluminium sample over time



Relative humidity system model: RHC040 with 3-axis scanning capabilities

Features

- Work function measurement by Kelvin probe
- Work function resolution of 1-3 meV
- Automatic control of relative humidity
- Atmospheric control to <1% oxygen
- Modular system for upgrades and add-ons

Applications

- Corrosion e.g protection and resistance
- Metals and metal alloys
- Thin films and surface oxides
- Organic and non-organic semiconductors
- Solar cells and organic photovoltaics



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System Specifications	RHC010	RHC020	RHC030	RHC040
Tip material/diameter	2 mm stainless steel tip			
Work function resolution	1-3 meV			
Sample scanning	Single-Point	50 mm x 50 mm	Single-Point	50 mm x 50 mm
Relative humidity control	Automatic: 20% to 80%			
Atmospheric control	RH Only	RH Only	Oxygen to <1%	Oxygen to <1%
Optical system	Front window		Colour camera	
Oscilloscope	Digital TFT oscilloscope for real time signal			
Test sample	Gold and aluminium test sample			
Breadboard footprint	900 x 600 mm			
Control supplied	PC control with dedicated software			
Detection system	Off-null with parasitic capacity rejection			
Warranty	12 months			

Upgrades and Add-Ons

- Ambient Pressure Photoemission Spectroscopy (APS)
- Surface Photovoltage (QTH or LED)
- Surface Photovoltage Spectroscopy (400-1000nm)
- Upgrade to Scanning Kelvin Probe System
- Sample Heating to 115°C



Relative humidity system model: RHC020 with 3-axis scanning

The Company

KP Technology Ltd was founded with the aim of bringing to the market new surface research tools. These tools have featured in over 250 peer-reviewed client publications in the last 3 years. KP Technology Ltd also performs a significant amount of material research and training consultancy, mostly based upon the work function (Φ) or surface potential evaluation of client samples. KP Technology Ltd holds international patents on their Ambient Pressure Photoemission Spectroscopy (APS) system for measuring absolute workfunction. Along with a strong research and development division and over 500 systems shipped worldwide, this has placed KP Technology Ltd as the leading supplier of Kelvin probes in the world.

Contact

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KP Technology Ltd is the proud winner of the
Queens Award for Enterprise:
International Trade 2013

